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CONFIRMATION NO. 1609

<b>SERIAL NUMBER</b> 10/673,581	<b>FILING OR 371(c) DATE</b> 09/30/2003 <b>RULE</b>	<b>CLASS</b> 250	<b>GROUP ART UNIT</b> 2881	<b>ATTORNEY DOCKET NO.</b> SEC.745c	
<b>APPLICANTS</b> Ji-Soo Kim, Seongnam-city, KOREA, REPUBLIC OF; Wan-Jae Park, Suwon-city, KOREA, REPUBLIC OF; Kyoung-Sub Shin, Seongnam-city, KOREA, REPUBLIC OF;					
<b>** CONTINUING DATA *****</b> This application is a CON of 09/640,088 08/17/2000 PAT 6,657,192 <i>JP</i>					
<b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 99-33858 08/17/1999 <i>JP</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 12/19/2003</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Allowance</i> Acknowledged <i>Pat. Berman</i> Examiner's Signature <i>JP</i> Initials		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 10	<b>TOTAL CLAIMS</b> 6	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> 20987					
<b>TITLE</b> Method of determining degree of charge-up induced by plasma used for manufacturing semiconductor device and apparatus therefor					
<b>FILING FEE RECEIVED</b> 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		